

<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> ( Not for submission under 37 CFR 1.99)	Application Number		10764345	
	Filing Date		2004-01-23	
	First Named Inventor	Tie Liu		
	Art Unit	4194		
	Examiner Name	DANTE RAVETTI		
	Attorney Docket Number	MS1-1811US		

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1	Venkatesan, et al., "Robust Image Hashing", Image Processing 2000, Piscataway, NJ USA IEEE, vol. 3, 10 September 2000, pp 664-666.	<input type="checkbox"/>
2		<input type="checkbox"/>

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Examiner Signature	/Dante Ravetti/	Date Considered	07/14/2009
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